



PATENT  
Docket No.: Q106-US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :  
Hisashi Tsukamoto et al. :  
Application No.: 10/031,022 : Group Art Unit: 1734  
Filing Date: January 14, 2002 : Examiner: N/A  
Title: LITHIUM THIN FILM :  
LAMINATION TECHNOLOGY :  
ON ELECTRODE TO INCREASE :  
BATTERY CAPACITY :

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GROUP 1700

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Dated April 24, 2003

Commissioner for Patents  
Washington, D.C. 20231

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